

# APPLICATION DATA SHEET

Electronic Version 0.0.11

Stylesheet Version: 1.0

Attorney Docket Number: **740756-2438**Publication Filing Type: **new-utility**Application Type: **utility**Title of Invention: **METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE**Suggested Representative Figure: **Fig. 1A****Legal Representative:**

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**Customer Number Correspondence Address:** 22204**\*22204\*****Foreign Priority:**

2001-049468

JP

2001-02-23

Priority Claimed

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